





## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## INFORMATION DISCLOSURE STATEMENT

APPLICANT:

Thomas Vogl

SERIAL NO.:

09/675,343 •

**GROUP ART UNIT: 2623** 

DATE FILED:

September 28, 2000

INVENTION:

"METHOD FOR RECOGNIZING AND

AVOIDING ETCH-CRITICAL REGIONS"

**Assistant Commissioner for Patents** Washington, D.C. 20231

SIR:

In accordance with the provisions of 37 CFR 1.56, 1.97 and 1.98, it is requested that a citation and examination of the references listed on the attached Form PTO-1449 be made during the course of the examination of the above-identified application.

## REMARKS

Applicant's attorneys have received German 196 31 160 and pages from Handbuch der Leiterplattentechnik as examples of standard technique. From a search, U.S. Patent No. 5,885,748, which claims priority from the same Japanese Application as German 196 31 160, was located. Copies of these three references are attached herewith. It is noted that the undersigned does not have or know of translations of the pages from the handbook.

Since these references are being submitted before any action on the merits has been received, it is respectfully submitted that no government fee is required for the Examiner to consider these references.

Respectfully submitted,

(Reg. No. 24,149)

SCHIFF HARDIN & WAITE

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DATED: March 30, 2001

## **CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on March 30, 2001.

James D. Hobart

Name of Applicant's Attorney

Signature

March 30, 2001

Date